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SUBCLASS
CLASSIFICATION

U.S. UTILITY Patent Application

CLASS. 347
PATENT OFFICE

APPLICATION NO. 09/787877	CONT/PRIOR D F	CLASS 257	SUBCLASS 347	ART UNIT 2877 2822	EXAMINER Soward
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APPLICANTS
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TITLE
Semiconductor substrate and its production method, semiconductor device comprising the same and its production method

PTO-2040
12/83